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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 8724

SERIAL NUMBER 09/909,013	FILING DATE 07/19/2001 RULE	CLASS 438	GROUP ART UNIT 2829	ATTORNEY DOCKET NO TIJ-29448
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APPLICANTS

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** CONTINUING DATA *****

NONE

SBG

** FOREIGN APPLICATIONS *****

Application # 2000-225229

filed July 26, 2000

S.B.G.

10/21/02

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 08/30/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged	Examiner's Signature	Initials	

ADDRESS

23494

TEXAS INSTRUMENTS INCORPORATED

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TITLE

Semiconductor package insulation film and manufacturing method thereof

FILING FEE RECEIVED 924	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following.	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> ~ ~
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